



Attorney Docket No. 09792909-5113

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Hideshi Abe

Application No. 09/878,841

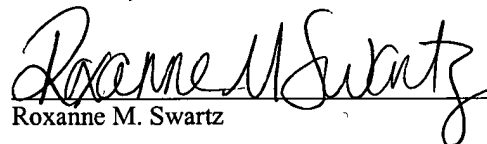
Filed: June 11, 2001

For: SEMICONDUCTOR APPARATUS  
MANUFACTURING METHOD  
THEREFOR, SOLID STATE IMAGE  
DEVICE AND MANUFACTURING  
METHOD THEREFOR

) Group Art Unit: 2812

) Examiner: Ron Everett Pompey

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO JULY 15, 2003 FINAL OFFICE ACTION**

Dear Sir:

This Amendment is submitted in response to the FINAL Office Action mailed July 15, 2003. Applicant respectfully requests amendment of the patent application, and reconsideration and allowance of the pending claims.

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